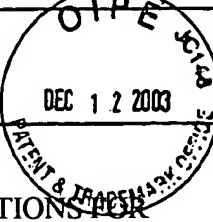


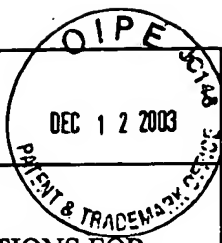
Page 1 of 13	FORM PTO-1449 	Atty. Docket No.: H0004489 (1139.1133101)	Serial No.: 10/697,660
		Applicant: 	
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		Filing Date: October 29, 2003	Group Art: unknown 1765

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FORM PTO-1449

Page 2 of 13


 Atty. Docket No.:
 H0004489
 (1139.1133101)

 Serial No.:
 10/697,660

 LIST OF PATENTS AND PUBLICATIONS FOR
 APPLICANT'S INFORMATION
 DISCLOSURE STATEMENT

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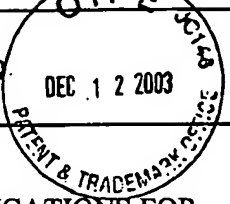
Filing Date:

October 29, 2003

Group Art:

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Page 3 of 13	FORM PTO-1449 	Atty. Docket No.: H0004489 (1139.1133101)	Serial No.: 10/697,660
		Applicant: 	
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		Filing Date: October 29, 2003	Group Art: unknown 1765

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
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Atty. Docket No.:
H0004489
(1139.1133101)

Serial No.:
10/697,660

LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION
DISCLOSURE STATEMENT

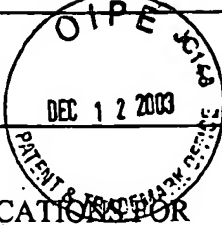
Applicant:

Filing Date:
October 29, 2003

Group Art:

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Page 5 of 13	FORM PTO-1449 	Atty. Docket No.: H0004489 (1139.1133101)	Serial No.: 10/697,660
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LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION
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FORM PTO-1449

Page 6 of 13


 Atty. Docket No.:
 H0004489
 (1139.1133101)

 Serial No.:
 10/697,660

 LIST OF PATENTS AND PUBLICATIONS FOR
 APPLICANT'S INFORMATION
 DISCLOSURE STATEMENT

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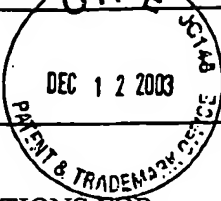
Filing Date:

October 29, 2003

Group Art:

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Page 7 of 13	FORM PTO-1449		Atty. Docket No.: H0004489 (1139.1133101)	Serial No.: 10/697,660
			Applicant: Filing Date: October 29, 2003 Group Art: unknown 1768	

LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION
DISCLOSURE STATEMENT

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
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Page 8 of 13 FORM PTO-1449	Atty. Docket No.: H0004489 (1139.1133101)	Serial No.: 10/697,660
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant:	
	Filing Date: October 29, 2003	Group Art: unknown 1765

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Page 9 of 13 FORM PTO-1449	Atty. Docket No.: H0004489 (1139.1133101)	Serial No.: 10/697,660
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant:	
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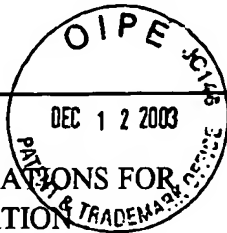


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FORM PTO-1449 Page 10 of 13	Atty. Docket No.: H0004489 (1139.1133101)	Serial No.: 10/697,660
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant:	
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FORM PTO-1449 Page 11 of 13	Atty. Docket No.: H0004489 (1139.1133101)	Serial No.: 10/697,660
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	Filing Date: October 29, 2003	Group Art: unknown 1768



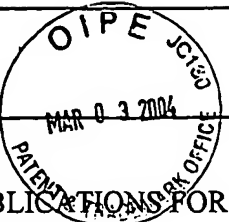
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Page 1 of 1	FORM PTO-1449 	Atty. Docket No.: H0004489 (1139.1133101)	Serial No.: 10/697,660
		Applicant: James R. Biard et al.	
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		Filing Date: October 29, 2003	Group Art: unknown 1765

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Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate

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